



ZJW  
AF

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

RALF VAN BENTUM  
MANFRED HORSTMANN

Serial No.: 10/624,712

Filed: July 22, 2003

For: TECHNIQUE FOR FORMING  
CONTACTS FOR BURIED DOPED  
REGIONS IN A SEMICONDUCTOR  
DEVICE

Examiner: Lan Vinh

OK to enter

Group Art Unit: 1765

LV

Att'y Docket: 2000.106700/DE0122

2/14/06

Customer No.: 23720

**RESPONSE TO FINAL OFFICE ACTION DATED JANUARY 6, 2006**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING  
37 C.F.R 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

January 26, 2006  
\_\_\_\_\_  
Date

*Mary Paul*  
Signature

This paper is submitted in response to the Final Office Action dated January 6, 2006, for which the three-month date for response is April 6, 2006.

No fees are believed to be due in connection with the present paper. However, should any fees be required under 37 C.F.R. §§ 1.16 to 1.21, the Director is authorized to deduct such fees from the Advanced Micro Devices, Inc. Deposit Account No. 01-0365/DE0122.<sup>1</sup>

Reconsideration of the application in view of the following amendments and remarks is respectfully requested.

<sup>1</sup> In the event the monies in that account are insufficient, the Director is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.106700.